



Attorney's Docket No.: 10417-074001 / F51-129328M/SMI

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Noriaki Sakamoto et al.      Art Unit : 2815  
Serial No. : 09/821,361      Examiner : Chris C. Chu  
Filed : March 29, 2001  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE  
SAME

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 14, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

October 14, 2004

Signature

Jennifer L. Hess

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